

Electronic Patent Application Fee Transmittal

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| Application Number: | 10615915 |
| Filing Date: | 10-Jul-2003 |
| Title of Invention: | Plasma processing apparatus |
| First Named Inventor/Applicant Name: | Yohei Yamazawa |
| Filer: | Marvin Jay Spivak/Karina De Leon |
| Attorney Docket Number: | 227430US26 |

Filed as Large Entity

Utility under 35 USC 111(a) Filing Fees

| Description | Fee Code | Quantity | Amount | Sub-Total in USD(\$) |
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| Basic Filing: | | | | |
| Pages: | | | | |
| Claims: | | | | |
| Miscellaneous-Filing: | | | | |
| Petition: | | | | |
| Patent-Appeals-and-Interference: | | | | |
| Post-Allowance-and-Post-Issuance: | | | | |
| Extension-of-Time: | | | | |
| Extension - 1 month with \$0 paid | 1251 | 1 | 130 | 130 |

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